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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Eiko Suzuki
Serial No.: Unassigned
Filed: Herewith
For: ID RECOGNITION APPARATUS AND ID RECOGNITION SORTER
SYSTEM FOR SEMICONDUCTOR WAFER

Docket: 14467
Group Art Unit: Unassigned
Dated: April 6, 2001

JCS25 U.S. PTO
09/828003
04/06/01

Assistant Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §§ 1.97 and 1.98, it is requested that the following reference, which is also listed on the attached Form PTO-1449, be made of record in the above-identified case.

1. Japanese Laid-Open Patent Application No. 07296147 A, dated November 10, 1995, together with an English language abstract.

CERTIFICATE OF MAILING BY EXPRESS MAIL

Express Mail Mailing Label Number: EL 798805843 US
Date of Deposit: April 6, 2001

I hereby certify that this correspondence is being deposited with the United States Postal Service Express Mail Post Office to Addressee service under 37 C.F.R. '1.10 on the date indicated above and is addressed to the Assistant Commissioner of Patents and Trademarks, Washington, D.C. 20231.


Dated: April 6, 2001


Michelle Mustafa

Applicant is submitting a copy of the above-cited reference. The relevance of this reference is cited in the specification.

Inasmuch as this Information Disclosure Statement is being submitted in accordance with the schedule set out in 37 C.F.R. § 1.97(b), no petition, certification or fee is required. Consideration of this Information Disclosure Statement is respectfully requested.

Respectfully submitted,



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